

Atty Dkt. No.  
33082M083



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yutaka Takahashi, et al.

Serial No.: 09/864,374

Group Art Unit: Unassigned

Filed: May 25, 2001

Examiner: Unassigned

For: METHOD OF FORMING OXYNITRIDE FILM OR THE LIKE AND SYSTEM  
FOR CARRYING OUT THE SAME

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an  
Information Disclosure Citation Form (PTO-1449) and a copy of each document cited therein.

It is respectfully requested that each cited document be considered by the Examiner in  
the above-identified patent application and that each cited document be made officially of record  
therein. It is further requested that a listing of the same appear on the face of any patent which  
may issue from this application.

A first Official Action has not yet issued for this application. Therefore, it is  
respectfully urged that no fees are required for the Examiner's consideration of this Information  
Disclosure Statement.

Respectfully submitted,  
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